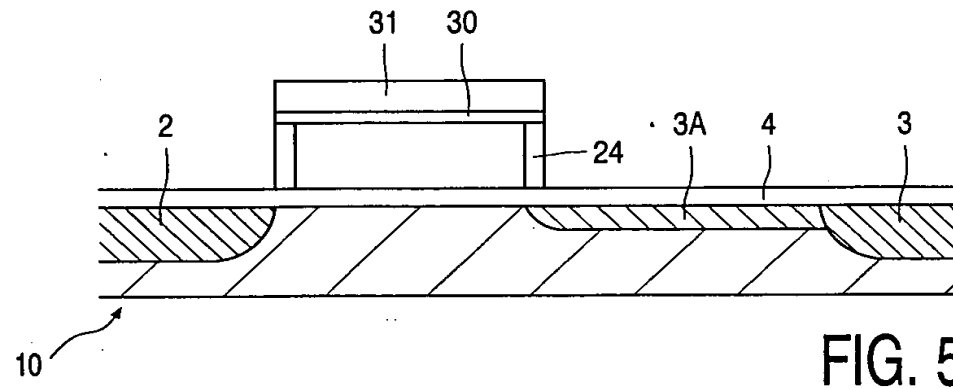
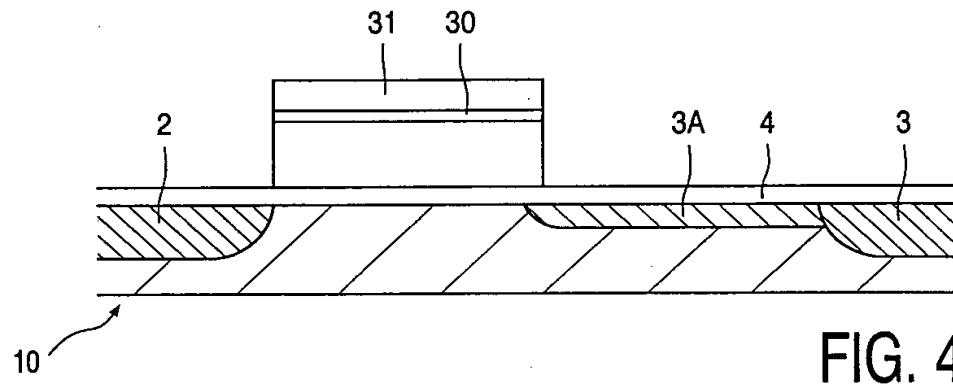
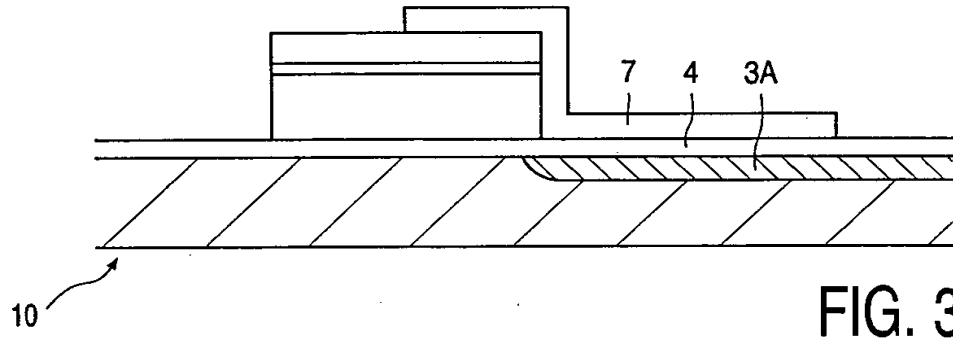
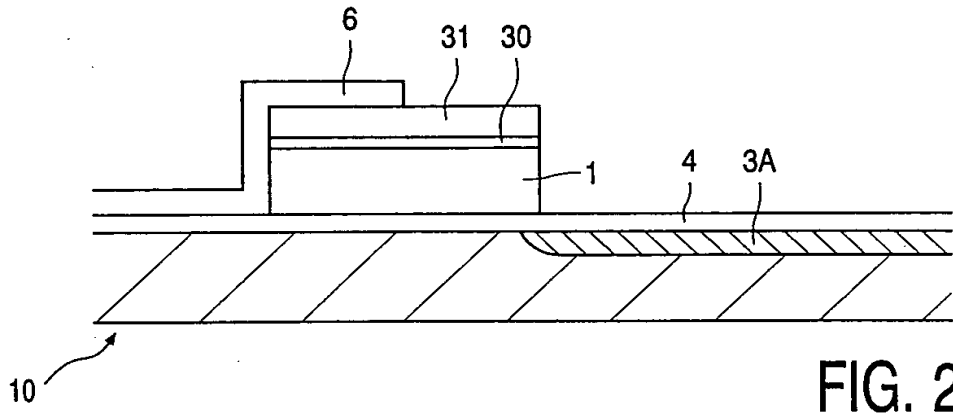


APPROVED	O.G. FIG.	
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APPROVED	O.G. FIG.
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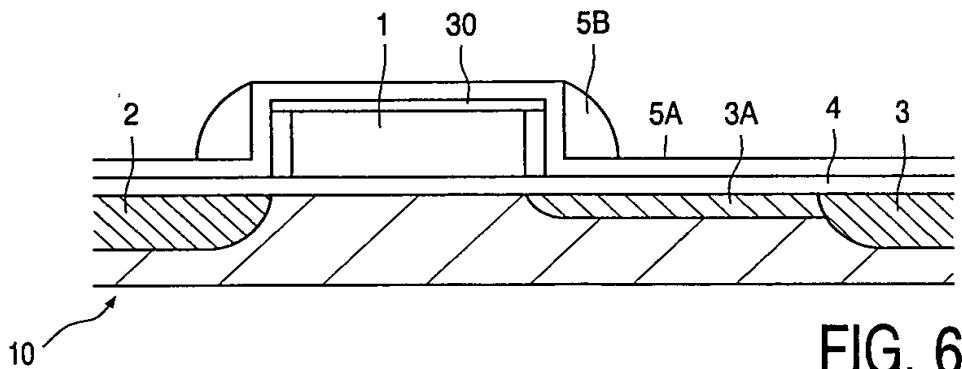


FIG. 6

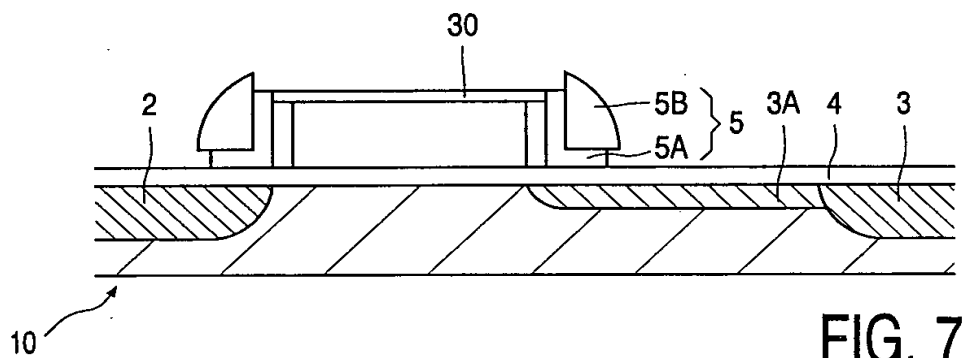


FIG. 7

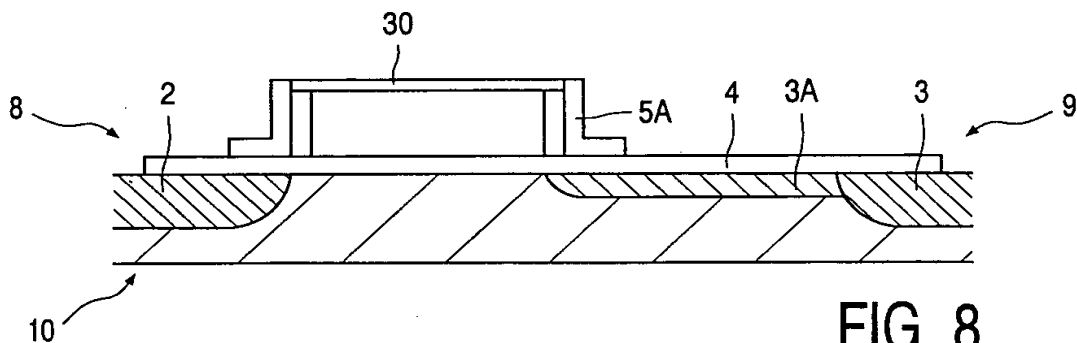


FIG. 8

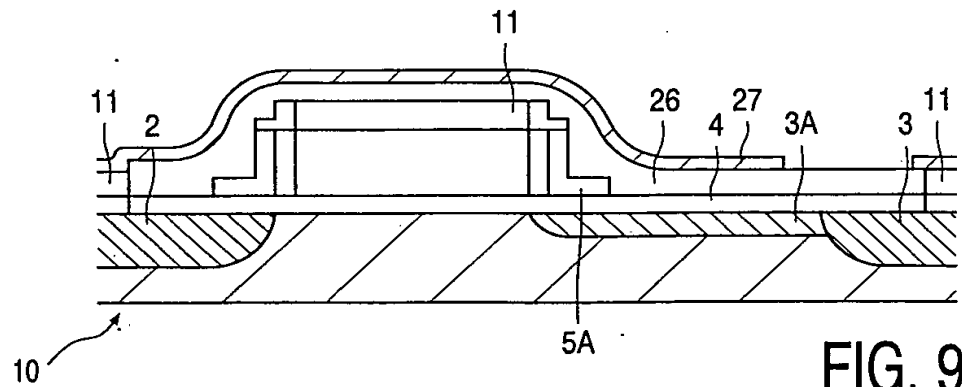


FIG. 9